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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Aaron Frank, et al. Docket No.: TI-33974  
Serial No.: 10/645,975 Art Unit: 1742  
Filed: August 22, 2003 Examiner: William T. Leader  
Customer No. 23494 Conf. No.: 8382  
For: System for In Situ Seed Layer Remediation

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on the date shown below:

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<input type="checkbox"/> CONTINUATION APP'N (# Pages)		<input checked="" type="checkbox"/> Election	
<input type="checkbox"/> DIVISIONAL APP'N			
NAME OF INVENTOR(S): Aaron Frank, et al.		RECEIPT DATE & SERIAL NO.:	
TITLE OF INVENTION: System for In Situ Seed Layer Remediation		Serial No.: 10/645,975	
TI FILE NO.: <b>TI-33974</b>		Filing Date: August 22, 2003	
DEPOSIT ACCT. NO.: 20-0668			
FAXED: 12/15/2005			
DUE: 12/25/2005			
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Art Unit:	1742	Examiner:	William T. Leader
Customer No.:	23494	Conf. No.:	8382
Title:	System for In Situ Seed Layer Remediation		

ELECTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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<i>Marianna Smith</i> Marianna Smith	<u>12-15-05</u> Date

Dear Sir:

With respect to the Restriction Requirement mailed on 11/28/2005, the Examiner has restricted the instant application to the invention of Group I (Claims 1-17), or Group II (Claims 18-21). In light of this, Applicants elect to pursue Group I, (Claims 1-17) without traverse.

Respectfully submitted,



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